Under the Par	per Reduction Act of 1995, no	persons :	U.S. Patent are required to respond to a collection			PTO/SB/21 (09 7/31/2006, OMB 0651-4 ARTMENT OF COMME	0031
TRANSMITTAL			Application Number	10/658,422			iber.
			Filing Date	Sep 10, 2003 KINOSHITA, Kezuto CENTRAL Page			
FORM (to be used for all correspondence after initial filling)		First Named Inventor	₹/V				
		Art Unit	3186			ax q	
		filing)	Examiner Name	PADGETT.	PADGETT, Marianne L		
Total Number of Pages in This Submission			Attorney Docket Number	KAGEI-0100-DIV			
		ENG	1 Agusta				_
	-	ENC	LOSURES (Check all the	at apply)	_		
Fee Transmittal Form		🗀	Drawing(s)	C	After Allowan	ce communication to	(TC)
Fee Attached			Licensing-related Papers			nunication to Board of	
x Amendment / Reply			Petition		Appeals and I Appeal Com	munication to TC	
After Final			Petition to Convert to a		Appeal Notic	e, Brief, Reply Brief)	l
Affidavits/declaration(s)			Provisional Application Power of Attorney, Revocation		<u> </u>		l
			Change of Correspondence Address		_ Status Letter		I
Extension of Time Request		$ \sqcup$	Terminal Disclaimer	Other Enclose below):	eure(s) (please identi	fy	
Express Abandonment Request			Request for Refund	1			
Information Disclosure Statement			CD, Number of CD(s)				
		Landscape Table on CD					
Certified Copy of Priority Document(s)							
Reply to Missing Parts/		Remarks Response to non-compliant amendment showing canceled claims					
Incomplete Application Reply to Missing Parts under		,					
	FR 1.52 or 1.53						- [
	SIGN	TUDE	OF ADDITIONAL APPROXIMATION				— [
SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT Firm Name City Main a Division D							
Signature	ure Olds, Majer & Richardson, PLLC						
Printed name	Timothy J. Maier						
Date	November 1, 2005			Reg. No	51986		-
				Trog. Ito	. 31860		
			CATE OF TRANSMISSION				
I hereby certify that sufficient postage as date shown below.	this correspondence is be s first class mail in an envi	ing facsin Hope add	nile transmitted to the USPTO or ressed to: Commissioner for Pate	deposited with	the United State 1450, Alexandria,	s Postal Service with VA 22313-1450 on the	
Signature 2th 7th							
Typed or printed na	me Timothy J. Maier				Data May		

This collection of information is required by 37 CFR 1.5. The information is required to obtain or retain a benefit by the public which is to fife (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.11 and 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date

November 1, 2005

in you need assistance in completing the form, call 1-800-PTO-9189 and select option 2.

p.2

Serial No. 10/658,422 Reply to Office Action dated <u>July 19, 2005</u> Docket No. KAGEI-0100-DIV

Amendments to the Claims:

This listing of claims will replace all prior versions, and listings, of claims in the application:

What is claimed is:

1-30. (Canceled)

31. (New) A method for cleaning a substrate surface on a moving conveyor, comprising:

dry washing the substrate to introduce the substrate into a mixed atmosphere of an inert gas and water vapor under irradiation of ultraviolet light from a dielectric barrier discharge lamp;

decomposing organic substances deposited on the surface of the substrate with the dielectric barrier discharge lamp while splitting water vapor into a reducing active member [H •] and an oxidative active member [• OH] to cause reactions with the decomposition of the organic substances by means of the reducing and oxidative members [H •] and [• OH];

wet washing step the substrate to remove inorganic contaminants by supplying washing water on the surface of the substrate; and

drying the substrate to eliminate washing water from the substrate surface.

32. (New) A method for applying a liquid developer on a substrate surface on a moving conveyor, comprising:

Serial No. 10/658,422

Docket No. KAGEI-0100-DIV

Reply to Office Action dated July 19, 2005

wet washing the substrate by supplying washing water to the surface of the substrate;

drying the substrate to eliminate washing water from the substrate surface;

placing the substrate in a mixed atmosphere of an inert gas and water to improve the contact angle of the substrate surface and thus improving the surface of the substrate, the inert gas and water vapor being under irradiation of ultraviolet light from a dielectric barrier discharge lamp to decompose organic substances deposited on a surface of the substrate while splitting water vapor into a reducing active member [H •] and an oxidative active member [• OH];

subjecting the reducing and oxidative members [H •] and [• OH] to reactions with decomposition products of the organic substances; and

coating the surface of the substrate with a liquid developer.